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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PRIORITY Application Serial No. 10/226,005
Confirmation No. unknown
PRIORITY Filing Date August 21, 2002
Inventor.... H. Daniel Dulman et al.
Assignee.... Micron Technology, Inc.
Group Art Unit.... unknown
Examiner unknown
Attorney's Docket No. MI22-2514
Customer No. 021567
Title: Methods Of Forming Aligned Structures With Radiation-Sensitive Material

PRELIMINARY AMENDMENT

To: Mail Stop PATENT APPLICATION
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

From: David G. Latwesen (Tel. 509-624-4276; Fax 509-838-3424)
Wells St. John P.S.
601 W. First Avenue, Suite 1300
Spokane, WA 99201-3828

AMENDMENTS